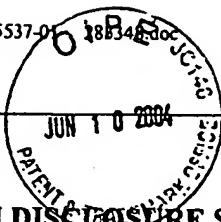


INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Attorney Docket Number	6500-65537
				Application Number	Not yet assigned
				Filing Date	Concurrently Herewith
				First Named Inventor	Novak
				Art Unit	Not yet assigned
				Examiner Name	Not yet assigned
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EXAMINER SIGNATURE:	<i>RDS</i>	DATE CONSIDERED:	3/03/2006
<p>* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>			



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Attorney Docket Number	6500-65537-01
Application Number	10/765,703
Filing Date	January 26, 2004
First Named Inventor	Novak
Art Unit	2872
Examiner Name	Not yet assigned

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**EXAMINER
SIGNATURE:**

RMJ

DATE

CONSIDERED:

3/03/2006

* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.